

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : H. Zhang Art Unit : 2826
Serial No.: 09/804,654 Examiner : F. Abraham
Filed : March 12, 2001
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated January 3, 2002,
Paper No. 7, in the above-referenced application, kindly
consider the following remarks in connection with the above-
identified application.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being
deposited with the United States Postal Service as first class mail with
sufficient postage on the date indicated below and is addressed to the
Commissioner for Patents, Washington, D.C. 20231.

May 1, 2002

Date of Deposit

Signature

Susan Regan

Typed or Printed Name of Person Signing Certificate